



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Satoshi SASAKI et al.

Application No.: 10/663,811

Filed: September 23, 2003

Docket No.: 117164

For: PIEZOELECTRIC CERAMIC COMPOSITION PIEZOELECTRIC ELEMENT AND  
PRODUCTION METHOD THEREFOR

**CLAIM FOR PRIORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The benefit of the filing dates of the following prior foreign applications filed in the following foreign country(ies) is hereby requested for the above-identified patent application and the priority provided in 35 U.S.C. §119 is hereby claimed:

Japanese Patent Application No. 2002-272037 filed on September 18, 2002

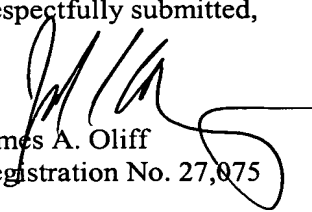
Japanese Patent Application No. 2003-096661 filed on March 31, 2003

In support of this claim, certified copies of said original foreign applications:

☒ are filed herewith.

It is requested that the file of this application be marked to indicate that the requirements of 35 U.S.C. §119 have been fulfilled and that the Patent and Trademark Office kindly acknowledge receipt of these documents.

Respectfully submitted,

  
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JAO:JSA/mlo

Date: July 19, 2003

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